

# IR Vacuum Systems Update

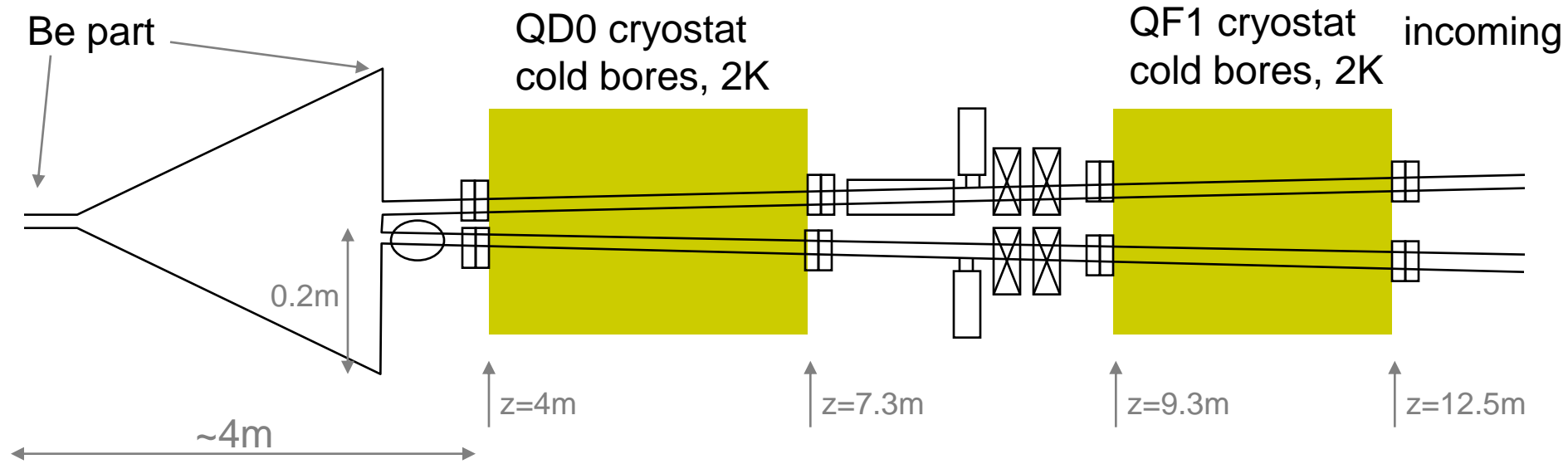
Oleg Malyshev  
ASTeC,  
STFC Daresbury Laboratory



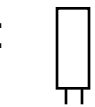
# Task

- Possible pumping schemes to provide the required vacuum
  - Required vacuum (Maruyama):
    - $10^{-8}$  Torr at RT  $\Rightarrow 3.2 \cdot 10^{14}$  molecules/m<sup>3</sup>
- Gas composition
- Ion induced pressure instability

# IR layout



Legend:



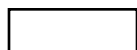
pump



BPM, strip-line



flanges



kicker, strip-line



bellows

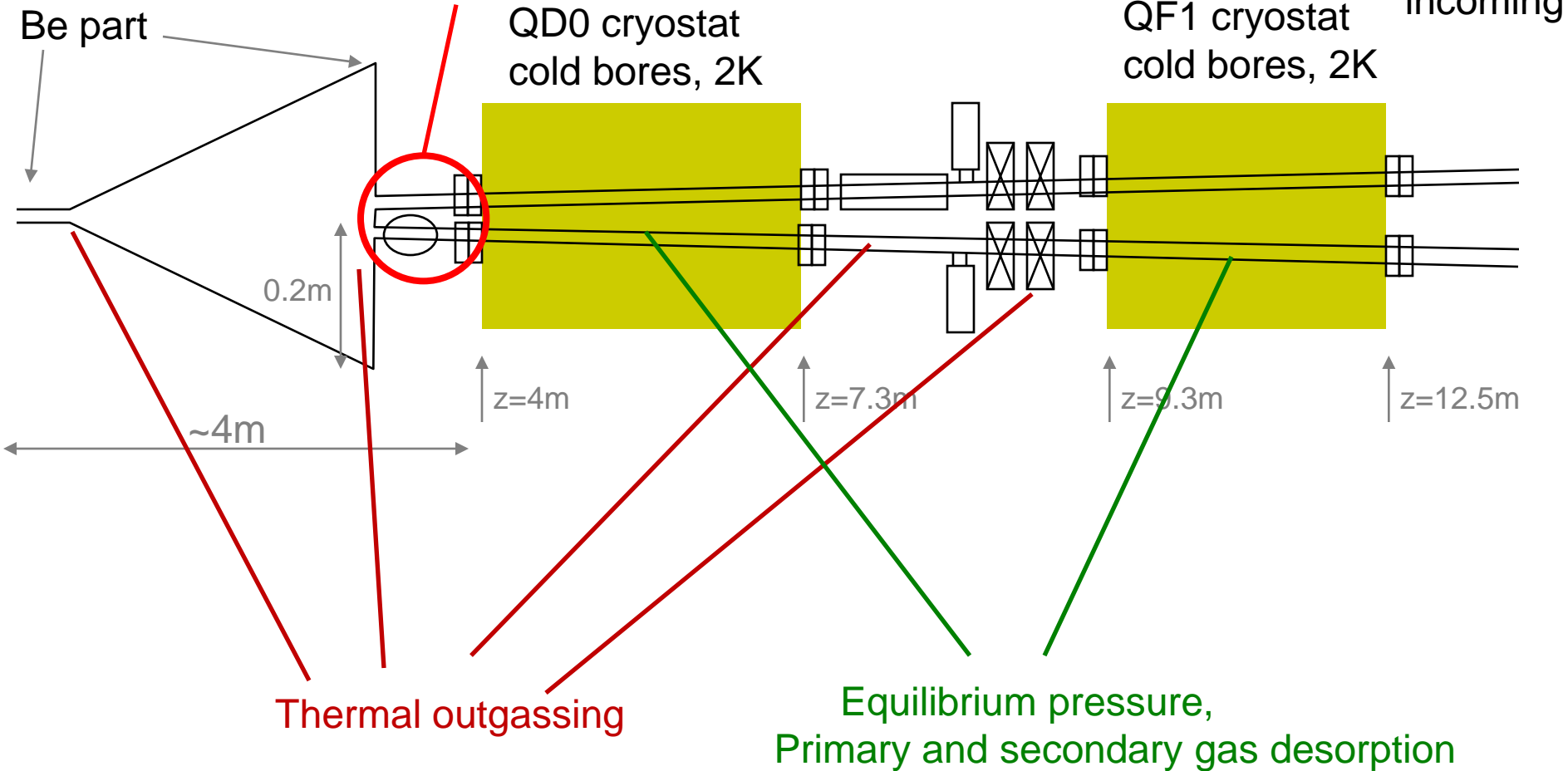


valve

Layout sketched  
by A. Seryi

# Outgassing

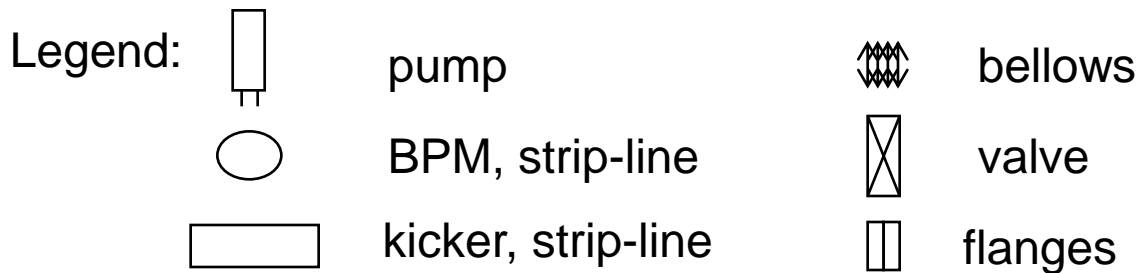
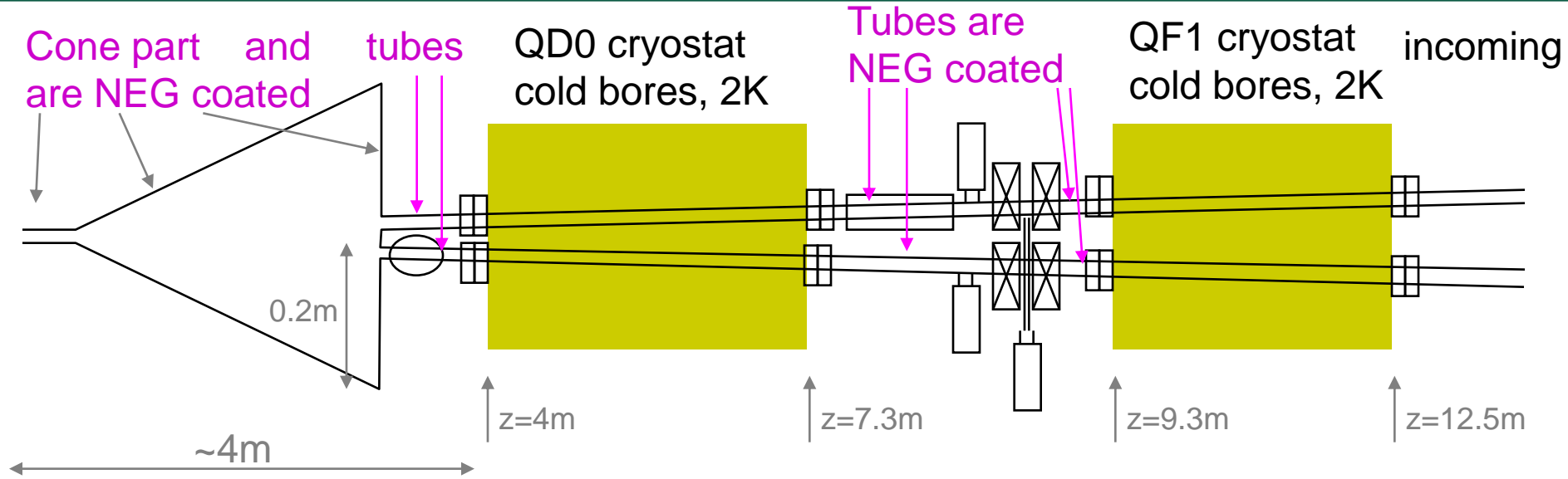
The most outgassing part due to  $\gamma$  and  $e^+/e^-$  bombardment.



## What was done in past

- Number of technical solutions were discussed at IRENG07 on 17<sup>th</sup> – 19<sup>th</sup> September 2007.
  - Y. Suetsugu (KEK): A Basic Design of IR Vacuum system
  - O. Malyshev (ASTeC): IR Vacuum Systems (First thoughts)
- WebEx meeting on 2nd October 2009
- The suggested solutions has questions to the detector design people

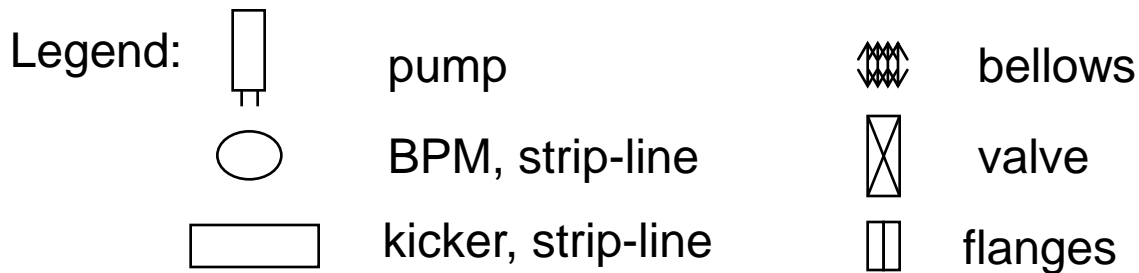
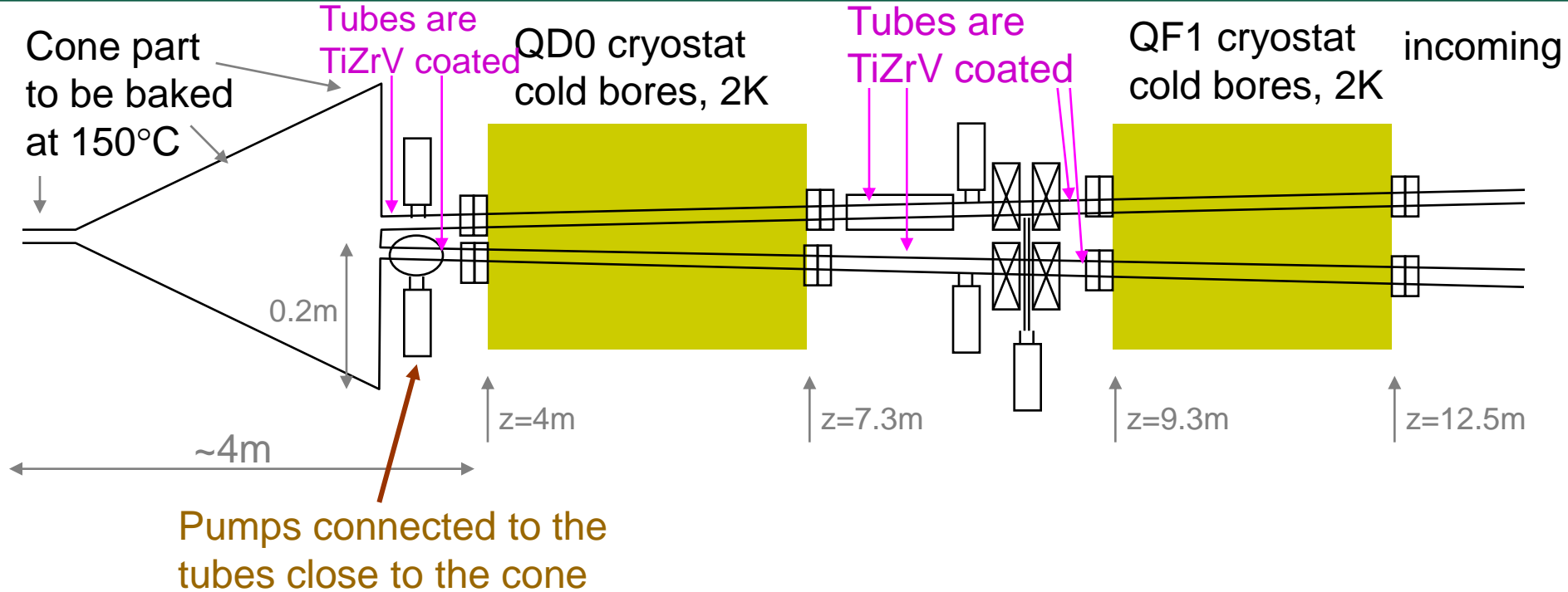
# Possible solutions: solution 1



A new 1- $\mu\text{m}$  thick NEG coating developed at ASTeC can be activated at 150°C

Dominant gases:  
 $\text{H}_2$  and  $\text{CH}_4$

## Possible solutions: solution 2



Dominant gases:  
 $H_2$ , CO and  $CH_4$

## Problems (or questions) for solutions 1 and 2

- Is bakeout to 150°C *in-situ* is possible?
  - ASTeC NEG coating can be activated at 150°C
  - Uncoated parts - to remove water and reduce outgassing
- What is maximum tolerable bakeout temperature?
- What available gap for bakeout tapes.
  - Possible solution is a thin bakeout coating developed at ASTeC on outer part of vacuum vessel.
    - 0.2-mm thick
    - Self regulated power output ('programmed' to selected highest temperature)
    - Can be optimised to AC (6-240V) or DC (6-12-24 V) power supply

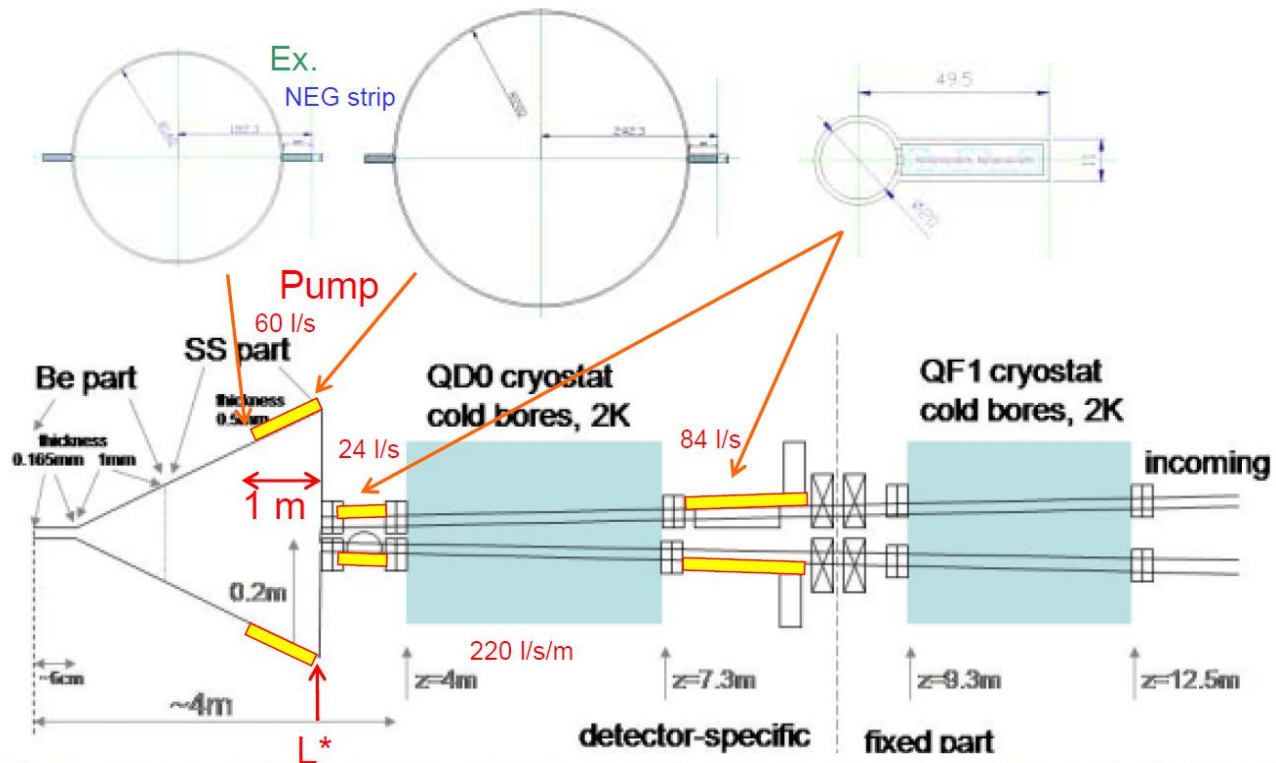


# Possible solutions: solution 3 (no bakeout) – Y. Suetsugu



## Pump system\_6

- For example, NEG pumps at the last 1 m of cone

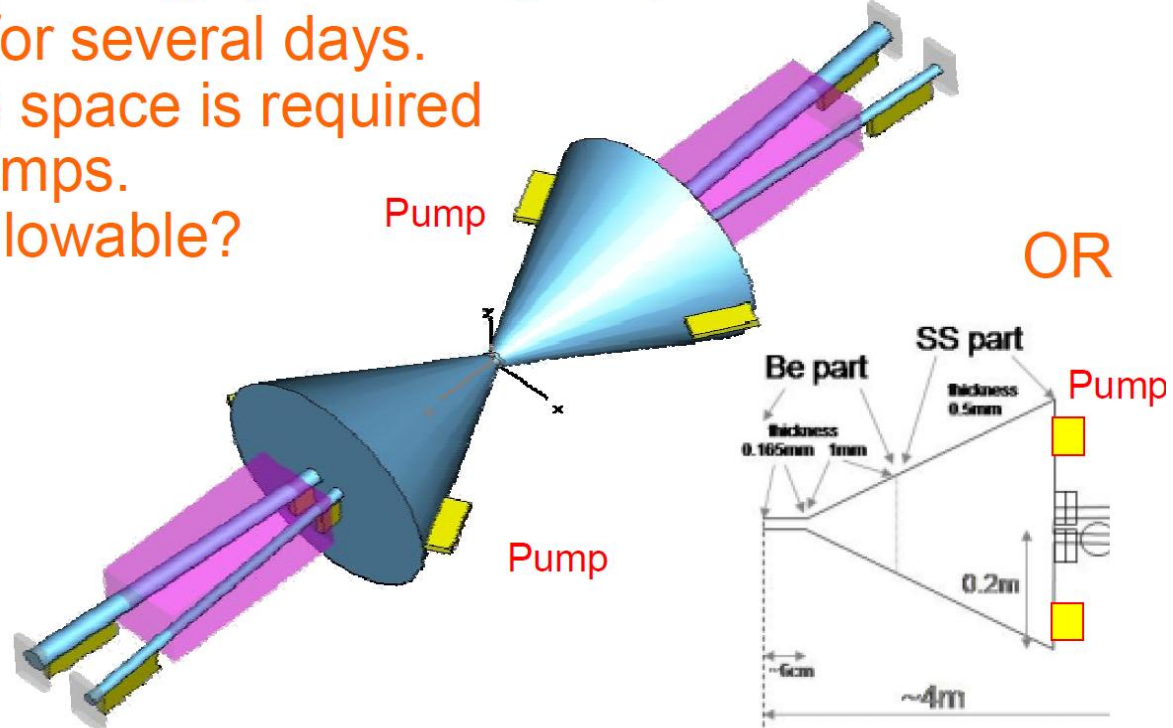


# Problems (or questions) for solutions 3 – Y. Suetsugu



## Pump system\_9

- If some pumps (~120 l/s) is prepared at cone, no *in-situ* baking system may be possible.
- Wait for several days.
- Some space is required for pumps.
- Is it allowable?



# Possible solutions: solution 4 (no bakeout) – CERN

Same as solution 3 but a **sputter ion pump** in the detector solenoid field in stead of NEG strips.

## Advantages:

- pumps all gases while NEG does not pump  $C_xH_y$  and noble gases

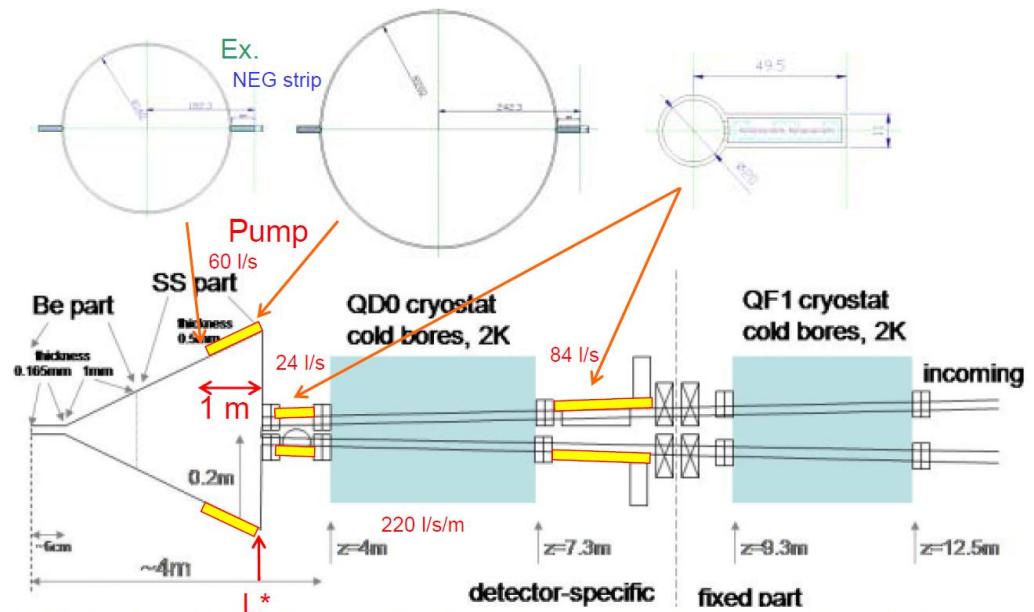
## Disadvantage:

- does not work then solenoid is off
- has to be designed



## Pump system\_6

- For example, NEG pumps at the last 1 m of cone



2007/09/17-21 SLAC

IRENG07

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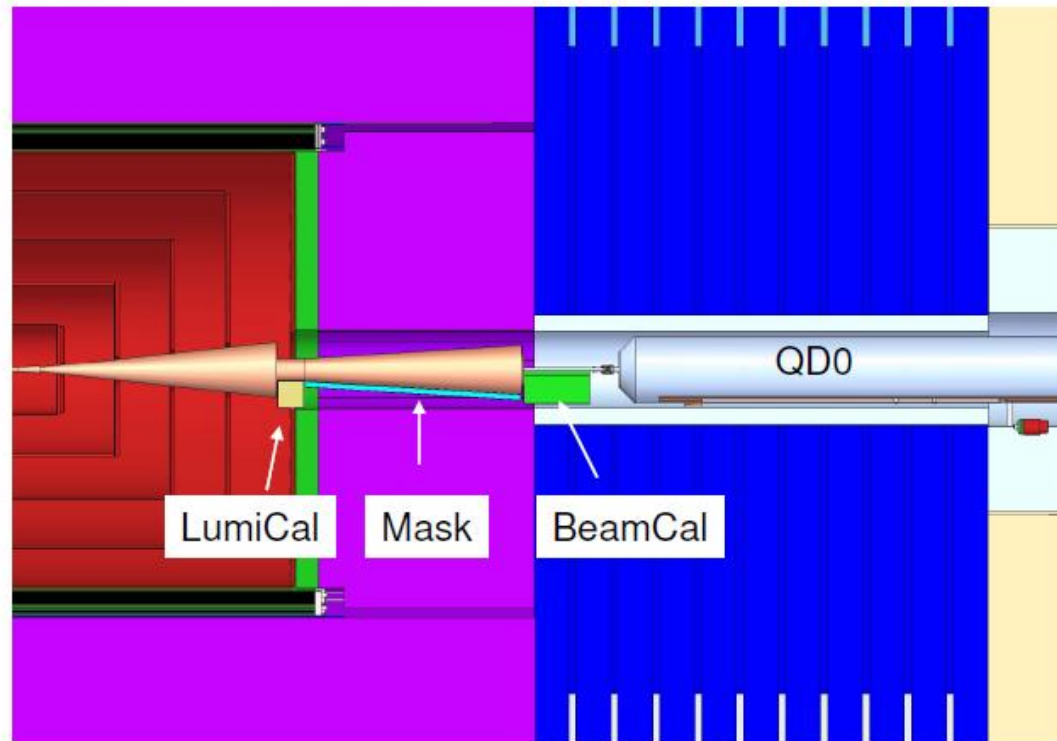
# No space for a pump - What about NEG coating?



## SiD Forward Region

No Space for Vacuum pump in the SiD Forward region

A slide from  
a previous talk  
by Dr. Maruyama



Do we need vacuum pumps inside the detector?

## Other possibilities

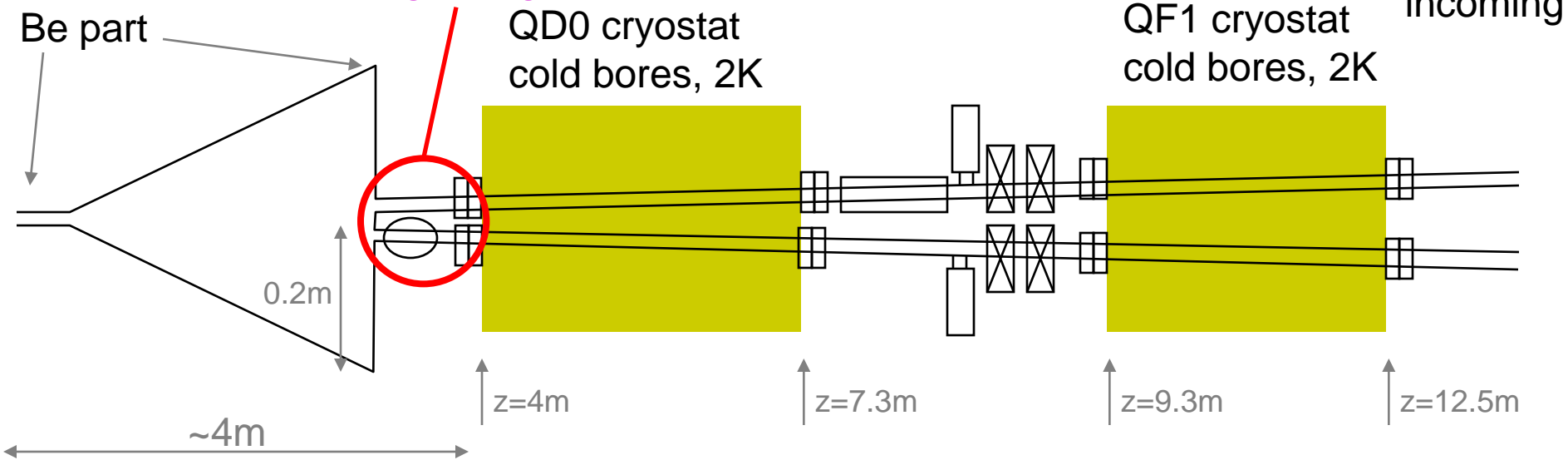
- *Low outgassing coating, ex: Ti, Au, etc.*
  -
- *Ex-situ* bakeout/activation
  - It could be quite efficient when
    - Either no went to air (like at SLS in Switzerland)
    - Or short (5-10 min.) went (filling with dry N<sub>2</sub>) quick assembly and pump down (like at DLS in UK)

## Assumption for gas density calculation

- Ougassing a week after bakeout (used for TPMC calculation on the following slide):
  - H<sub>2</sub>:  $10^{-11}$  mbar·l/(s·cm<sup>2</sup>)
  - CO:  $10^{-12}$  mbar·l/(s·cm<sup>2</sup>)
- Without bakeout after a week pumping (Suetsugu):
  - H<sub>2</sub>:  $2 \cdot 10^{-10}$  mbar·l/(s·cm<sup>2</sup>)
  - CO:  $2 \cdot 10^{-11}$  mbar·l/(s·cm<sup>2</sup>)

# Tube between cone and QD0

The most outgassing part due to  $\gamma$  and  $e^+/e^-$  bombardment.





## Photon and $e^+/e^-$ stimulated desorption:

The 'critical' energy of photon near IR is  $\varepsilon_c \sim 0.5$  MeV.

Photon flux  $\Gamma \sim 7 \cdot 10^{10}$   $\gamma/(\text{s} \cdot \text{m})$  (calculated by Dr. Takashi Maruyama)

- Estimated pressure raise due to photon stimulated desorption is much larger than thermal:
  - $P(\text{H}_2) = 1.5 \cdot 10^{-8}$  Torr;  $P(\text{CO}) = 3 \cdot 10^{-9}$  Torr
- $e^+/e^-$  flux 10 particle/s (per metre or what?)
- $e^+/e^-$  stimulated desorption may lead to an order of magnitude larger pressure raise.

=> these tubes must be also NEG coated and activated



## QD0 cold bore

- Gas density with no beam is
  - negligible at  $T=2$  K (except for He)
  - too high at  $T=4.5$  K (equilibrium  $H_2$  pressure for  $>0.1$ ML).
- Gas density with a beam increase due do:
  - Photon, electron, ions, lost positron and electron stimulated desorption inside the cold bore.
  - Gas from the IR vacuum vessel and connecting tube!
  - Desorbed gas cryosorbed and accumulated on the cryogenic walls
  - Accumulated molecules will be desorbed by photon, electron, ions, lost positron and electron.
  - **=> Gas density is growing with time**

# Cold bore – behaviour under SR

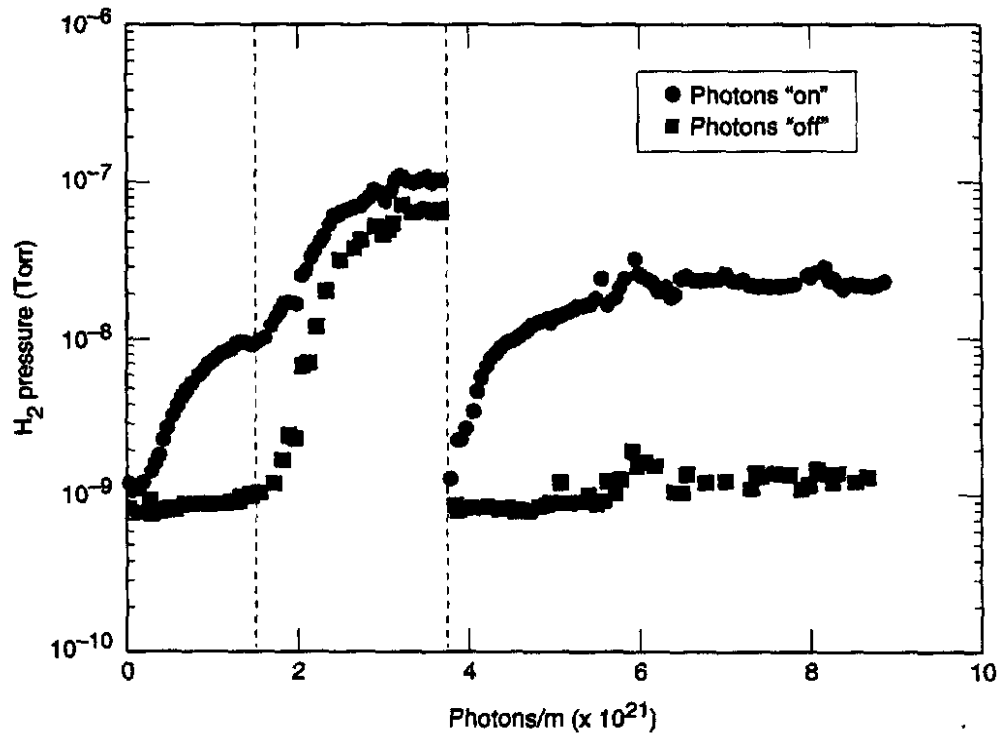


FIG. 1. Room-temperature RGA  $H_2$  pressure measured at the center of the 4.2-K beam tube vs integrated photon flux with photons on and photons off. The raw pressure difference “on” minus “off” has been normalized to  $1 \times 10^{16}$  photons/m/s. The vertical dashed lines correspond to features discussed in the text.

- Experiment was performed with photons with  $\varepsilon_c = 300$  eV
- Initial gas density will be quite good
- But after some dose there will be a **pressure bump** in a cryogenic vacuum chamber irradiated with photons and electrons

## Investigation of synchrotron radiation-induced photodesorption in cryosorbing quasiclosed geometry

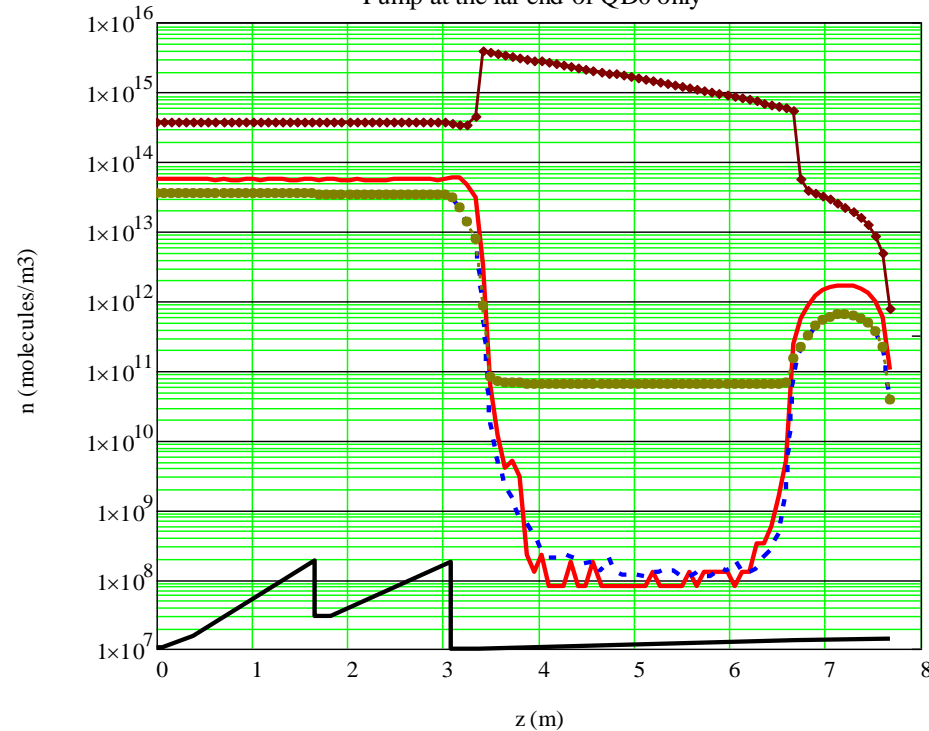
V. V. Anashin, O. B. Malyshev, and V. N. Osipov  
Budker Institute of Nuclear Physics, Novosibirsk, Russia

I. L. Maslennikov and W. C. Turner  
Superconducting Super Collider Laboratory, Dallas, Texas 75237

# Gas density inside SiD and near IR without NEG coating

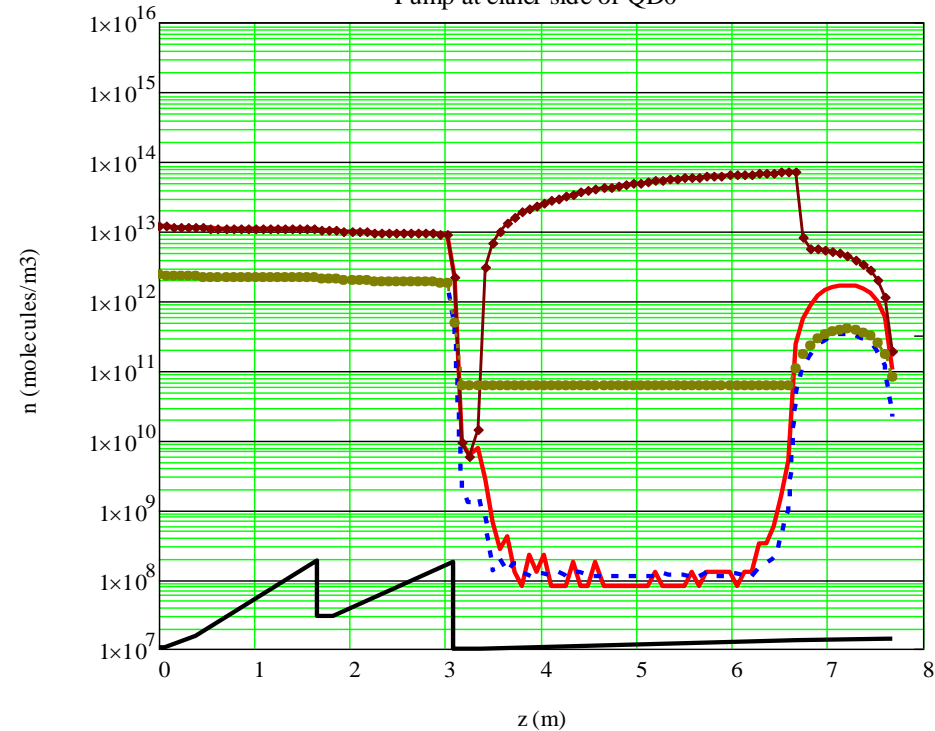
Required vacuum:  $10^{-8}$  Torr at RT  $\Rightarrow 3.2 \cdot 10^{14}$  molecules/m<sup>3</sup>

Pump at the far end of QD0 only



- H2 initial gas density with end pump only
- - - CO initial gas density with end pump only
- H2 gas density after long time, pump one side only
- CO gas density after long time, pump one side only
- Vessel shape

Pump at either side of QD0

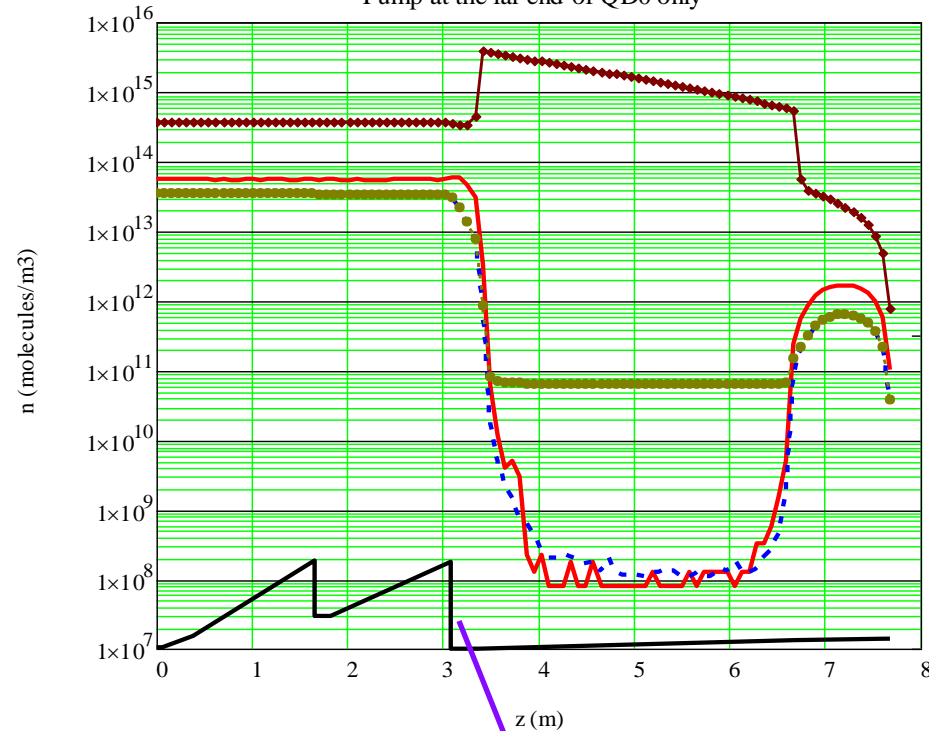


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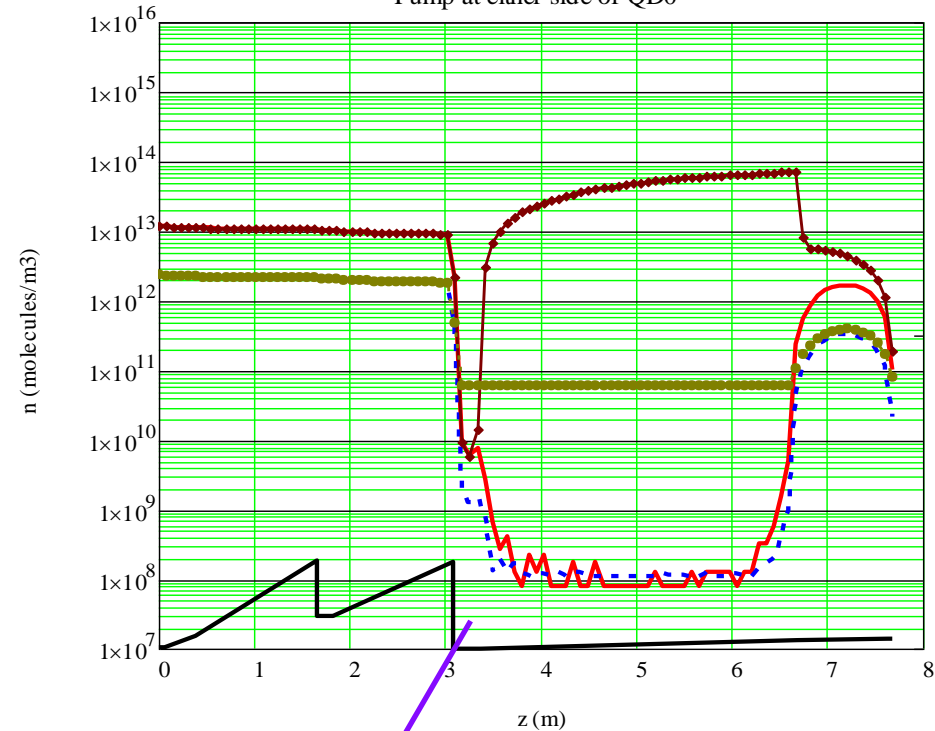
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- Vessel shape

$e^+/e^-$  stimulated desorption is not included as some clarification is required

## General questions (listed by Y. Suetsugu plus mine)

- There are a few possible solutions for IR vacuum system
- To choose one need to consider that the pumping system design depends on:
  - How long we can wait after installation and after air vent until the pressure decreases to the allowable level.
    - Days or weeks?
    - Strategy of push-pull
  - Whether or how often we have to expose the IR beam pipe to air
    - NEG coating lifetime is about 60 vents
  - Warming up and cooling down scenario for QD0
- We need a typical operation pattern.

## General questions

- Required pressure
  - Gas spectrum depends on technical solution, temperature, location, etc.
  - Ideally required vacuum should be given in gas density for a particular gas. For example:
    - $3.2 \cdot 10^{13} \text{ H}_2/\text{m}^3$  (hydrogen equivalent)
    - For other gases we can use the ratio of cross sections:
      - For the LHC design we used an *effective*  $\text{H}_2$  equivalent gas density given by:

$$n_{eff} = n(\text{H}_2) + 5.4 n(\text{CH}_4) + 7.8 n(\text{CO}) + 12.2 n(\text{CO}_2)$$

- Are these coefficient correct for the ILC?